



PATENT
Atty Dkt. AMAT/3819/DSM/BCVD/JW

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:
Suzuki, et al.

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Group Art Unit: 2818

Serial No.: 10/004,489

Confirmation No.: 9428

Examiner: Renee R. Barry

Filed: October 23, 2001

For: Method for Forming Film,
Method of Manufacturing
Semiconductor Device and
Film Forming Apparatus

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on August <u>27</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
<u>8/27/03</u> Date	<u>Keith M. Tackett</u> Signature

Dear Sir:

NOTICE OF CHANGE OF ADDRESS

Please change your records to show the addresses of record for the above-referenced application as follows:

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Respectfully submitted,

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